



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto IIDA et al.

Group Art Unit: 1714

Application No.: 10/586,953

Examiner: M. SONG

Filed: July 25, 2006

Docket No.: 128832

For: A SILICON SINGLE CRYSTAL, A SILICON WAFER, AN APPARATUS FOR
PRODUCING THE SAME, AND A METHOD FOR PRODUCING THE SAME

AMENDMENT WITH REQUEST FOR CONTINUED EXAMINATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In further reply to the March 4, 2011 Final Rejection, in view of the June 20, 2011
Advisory Action, and upon entry of the attached Request for Continued Examination, please
consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.